

Attorney's Docket No. 07977-052001 / US3053

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant : Hisashi Ohtani et al. Art Unit : 1765
Serial No.: 08/690,747 Examiner : Robert Kunemund
Filed : August 1, 1996
Title: METHOD FOR MANUFACTURING SEMICONDUCTOR DEVICE

Commissioner for Patents
Washington, D.C. 20231

*Duplicate*RESPONSE

In response to the action mailed May 18, 2001, please
consider the remarks as follows:

REMARKS

Claims 21, 25, and 37-96 are pending in the application.

Claims 21, 25, and 37 are rejected under the judicially
created doctrine of obviousness-type double patenting as
allegedly being unpatentable over claims 1-48 of U.S. Patent No.
6,065,518. Applicant respectfully disagrees with this rejection
and requests that this rejection be held in abeyance until the
claims are finally deemed allowable over the prior art cited by
the Examiner.

CERTIFICATE OF MAILING BY FIRST CLASS MAIL

I hereby certify under 37 CFR §1.8(a) that this
correspondence is being deposited with the
United States Postal Service as first class mail
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October 27, 2001

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